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022404

Case Docket Number: 59516-052

Customer Number: 20277

17302 U.S. PTO  
10784899  
022404



**UTILITY PATENT APPLICATION  
UNDER 37 CFR 1.53(b)**

Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing is the patent application of:

**INVENTOR: Zi-Kui LIU, Zhi-Jie LIU, Xiaoxing XI  
FOR: BORIDE THIN FILMS ON SILICON**

Enclosed are:

14 pages of specification, claims, abstract.  
 Declaration and Power of Attorney.  
 Priority Claimed- U.S. Provisional Application No. 60/450,321  
 Certified copy of \_\_\_\_\_  
 2 sheets of formal drawing.  
 An assignment of the invention to \_\_\_\_\_  
and the assignment recordation fee.  
 An associate power of attorney.  
 Information Disclosure Statement, Form PTO-1449 and references.  
 Return Receipt Postcard  
 Applicant is entitled to Small Entity Status.

Respectfully submitted,

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